



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of	)
Shunpei YAMAZAKI, et al.	)
Application No. 10/700,516	)
Filed: November 5, 2003	)
For: LASER IRRADIATION APPARATUS	)
AND METHOD OF FABRICATING	)
SEMICONDUCTOR DEVICE	) Date: July 26, 2004

## INFORMATION DISCLOSURE STATEMENT

U.S. Patent and Trademark Office 220 20<sup>th</sup> Street, South Customer Window, Mail Stop Missing Parts Crystal Plaza Two, Lobby, Room 1B03 Arlington, Virginia 22202

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. In accordance with the PTO notice dated July 11, 2003, waiving the requirement under 37 CFR 1.98 (a)(2)(i) for submitting copies of each cited U.S. Patent, for all U.S. national patent applications filed after June 30, 2003, no copies of U.S. Patents are enclosed. However, copies of foreign patents and non-patent literature are submitted under 37 CFR 1.98(a)(2).

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted

Teffrey L. Costellia Registration No. 35,483

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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

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Confirmation No.

Complete if Known

10/700,516

November 5, 2003

Filing Date
First Named Inventor
Shunpei YAMAZAKI, et al.

Art Unit
Confirmation No.

5919

Attorney Docket Number

740756-2666

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U.S. PATENT DOCUMENTS U.S. Patent Document Cite No.1 Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear Publication Date Name of Patentee or Number - Kind Code<sup>2</sup> (if known) Applicant of Cited Document 07/01/1997 Ishihara et al. 5,643,801 5,897,799 04/27/1999 Yamazaki et al. 5,900,980 05/04/1999 Yamazaki et al. 5,923,962 07/13/1999 Ohtani et al. 5,953,597 09/14/1999 Kusumoto et al. 5,959,779 09/28/1999 Yamazaki et al. 6,022,458 02/08/2000 Ichikawa 6,002,523 12/14/1999 Tanaka Yamazaki et al. 6,038,075 03/14/2000 08/06/2002 Voutsas et al. 6,429,097 B1 04/08/2003 Yamazaki 6,544,825 B1 6,548,370 B1 Kasahara et al. 04/15/2003 FOREIGN PATENT DOCUMENTS Examiner Initials Cite No.1 Foreign Patent Document Pages, Columns, **Publication Date** Name of Patentee or MM-DD-YYYY Application of Cited Document Lines, Where T<sup>6</sup> Country Code<sup>3</sup> Number<sup>4</sup> (if known) Relevant Passages or Relevant Figures JP 07-183540 07/21/1995 Hisashi Ohtani et al. Abstract JP 07-187890 07/25/1995 **FULL** OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS Examiner Cite Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the  $T^2$ Initials item (book, magazine, journal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published. Specification and Drawings for Related Application Serial No. 10/701,174 filed on November 5, 2003.

Examiner	Date	
Signature	Considered	
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